

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application Serial No. ....10757276  
Filing Date ..... January 14, 2004  
Confirmation No. .... 4316  
Inventor.....Beaman, Kevin L.  
Assignee .....Micron Technology, Inc.  
Group Art Unit ..... 2813  
Examiner ..... Smoot, Stephen W.  
Attorney's Docket No. .... MI22-2475  
Title:..... Method of Forming a Structure over a Semiconductor Substrate

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**


References - - See attached Form PTO/SB/08A-B

The attached Form PTO/SB/08 is submitted In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, and your attention is directed to the references listed on the attached Form PTO/SB/08. No admission is made regarding whether the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 2/1/08

By:   
James D. Shaurette  
39833